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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: W. SCHWARZENBACH et al. Confirmation No.: 9739

Application No.: 10/733,729

Group Art Unit: 2818

Filing Date: December 12, 2003

Examiner: David Nhu

For: METHOD OF MAKING CAVITIES IN A
SEMICONDUCTOR

Attorney Docket No.: 4717-9200

SUBMISSION OF FORMAL DRAWINGS

Mail Stop Issue Fee

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability mailed August 11, 2005, submitted herewith is a copy of one (1) sheet of replacement formal drawings including Figs. 3A, 3B, 3C and 5. Applicants respectfully request that the attached sheet of replacement drawings be substituted for the annotated drawings filed on July 27, 2005 and approved by the Examiner on August 11, 2005.

No fee is believed to be due for this submission. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

8/26/05
Date

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